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AMENDMENT TRANSMITTAL LETTER			Docket No. 03850/010001
Application No. 09/934,262-Conf. #6459	Filing Date August 21, 2001	Examiner K. T. Nguyen	Art Unit 2881

Applicant(s): Oliver Kienzle et al.

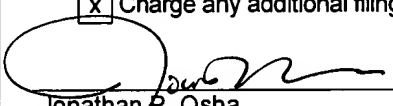
Invention: APPARATUS AND METHOD FOR EXPOSING A RADIATION SENSITIVE LAYER BY MEANS OF CHARGED PARTICLES AS WELL AS A MASK FOR THIS PURPOSE

TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	17	- 93 =		x	
Independent Claims	4	- 4 =		x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					0.00

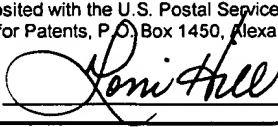
☒ Large Entity☐ Small Entity☒ No additional fee is required for this amendment.☐ Please charge Deposit Account No. _____ in the amount of \$ _____.
A duplicate copy of this sheet is enclosed.☐ A check in the amount of \$ _____ to cover the filing fee is enclosed.☐ Payment by credit card. Form PTO-2038 is attached.☒ The Director is hereby authorized to charge and credit Deposit Account No. 50-0591
as described below. A duplicate copy of this sheet is enclosed.☒ Credit any overpayment.☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.
Jonathan P. Osha
Attorney Reg. No.: 33,986

Dated: August 11, 2004

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I hereby certify that this correspondence is being deposited with the U.S. Postal Service as Express Mail, Airbill No. EV526068984US, in an envelope addressed to: MS AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: August 11, 2004

Signature:  (Toni Hill)

22511

PATENT TRADEMARK OFFICE



U.S. Patent Application Serial No. 09/934,262
Attorney Docket No. 03850/010001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :	Oliver KIENZLE, <i>et al.</i>	Art Unit :	2881
Serial No.:	09/934,262	Examiner :	Nguyen, Kiet
Filed :	August 21, 2001	Confirmation No.	6459
Title :	APPARATUS AND METHOD FOR EXPOSING A RADIATION SENSITIVE LAYER BY MEANS OF CHARGED PARTICLES AS WELL AS A MASK FOR THIS PURPOSE		

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY UNDER 37 CFR § 1.116

In response to the Office Action dated May 11, 2004, please amend the application as follows and consider the included remarks.

22511

PATENT TRADEMARK OFFICE